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T. Robinson  
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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Klaus F. Schuegraf et al. Examiner: Ori Nadav  
Serial No.: 08/902809 Group Art Unit: 2811  
Filed: July 30, 1997 Docket: 303.278US1  
Title: SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING  
POLYCIDING REOXIDATION

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
P.O.Box 1450  
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. § 1.97(b), it is believed that no fee or statement is required with the Information Disclosure Statement.

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

KLAUS F. SCHUEGRAF ET AL.

By their Representatives,

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By \_\_\_\_\_  
Robert E. Mates  
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Date 16 JUNE 2003

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**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner of Patents, P.O.Box 1450, Alexandria, VA 22313-1450, on this 16 day of June, 2003

Name Tina Rohaut

Signature Z. M.